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In re Application of
Hm — Michael J. Berman et al.
8-16-6 Application No.: 10/723,701
Filed: November 26, 2003
Attorney Docket No. 03-1494
For: Contact Resistance Device For Improved Process Control

WITHDRAWAL FROM ISSUE
37 CFR 1.313

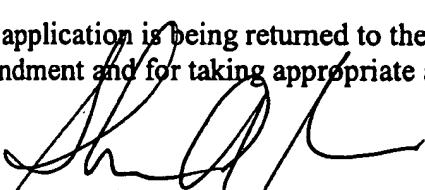
The purpose of this communication is to inform you that the above-identified application is being withdrawn from issue pursuant to 37 CFR 1.313.

The application is being withdrawn from issue because of unpatentability of at least one claim.

The US Patent and Trademark Office records reveal that the issue fee has not been paid. If the issue fee has been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Fee(s) Due, applicant may request that the previously submitted issue fee be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Fee(s) Due. If the application is abandoned, applicant may request either a refund or a credit to a Deposit Account.

Any question regarding this communication should be directed to Ha Nguyen, Supervisory Patent Examiner, at (571) 272-1678.

The application is being returned to the examiner for consideration of the preliminary amendment and for taking appropriate action.


Sharon Gibson, Group Director
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Semiconductors, Electrical and Optical
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